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MAINTENANCE

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Institute for Maintenance Science and Technology

ATMOSPHERIC PLASMA FOR SURFACE MODIFICATION

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IMST @ North Carolina State University

Materials Science and Engineering

www.imst.us

NC STATE UNIVERSITY



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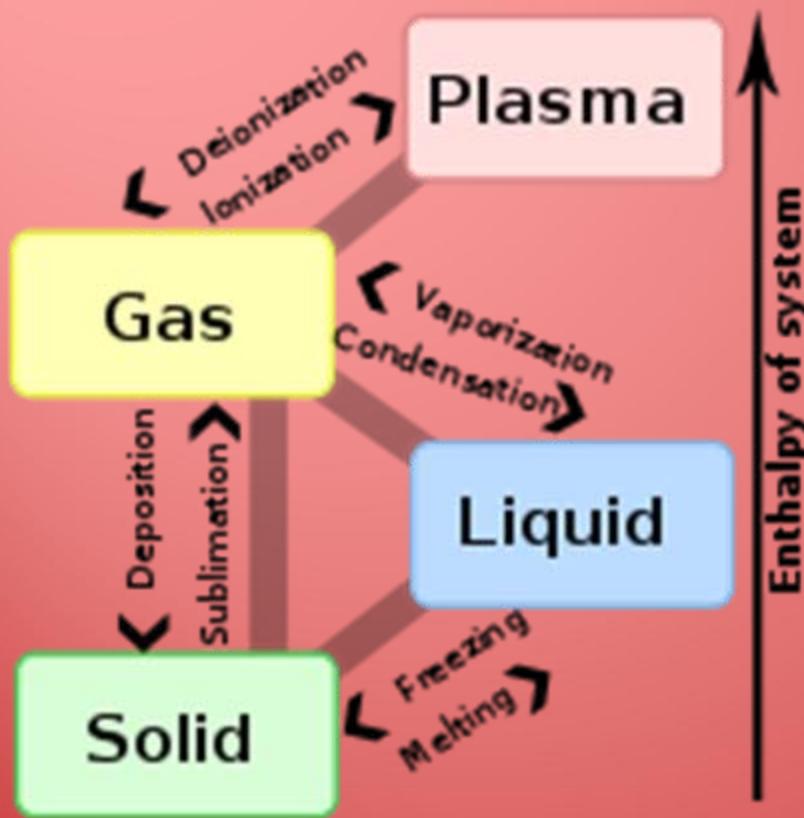


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Brief

- Atmospheric Plasma Explained
- Applications of Cold Plasma
- Commercial Devices
- Examples

4th State of Matter



>95% of matter in the universe is Plasma

Plasma generated by

- Heat
- Voltage
- EMR
- Laser
- Nuclear reactions

Atmospheric Plasma processing occurs at atmospheric pressure

Parallel Plate

Paschen's Law (1889) governs the breakdown of gas between plates

$$V = \frac{a(pd)}{\ln(pd) + b}$$

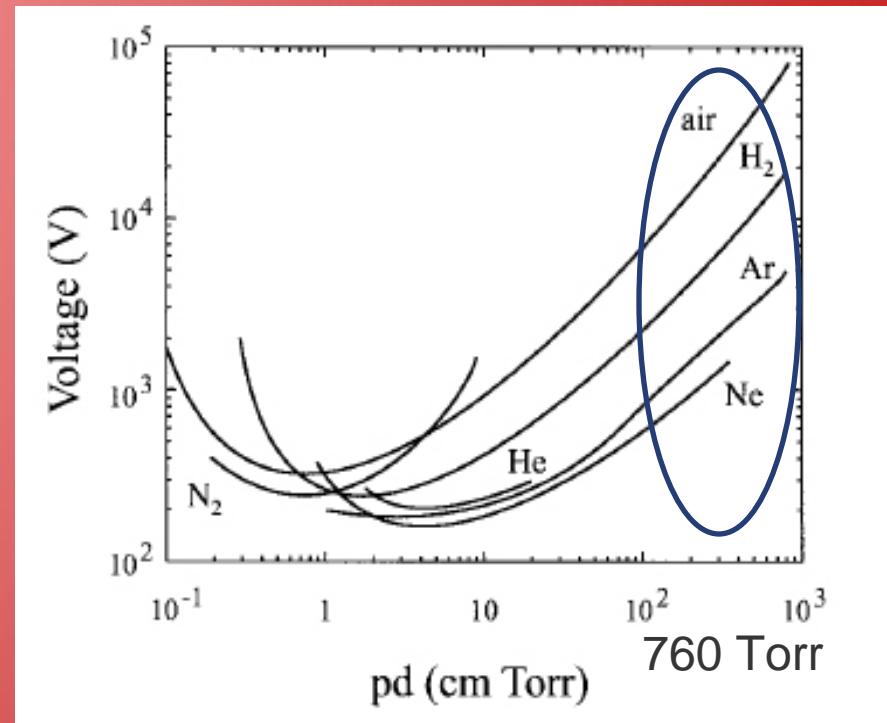
V = breakdown voltage

p = pressure

d = distance between electrodes

a and b are constants dependent on gas

$$pd = e^{1-b}$$



Paschen curves for common gases

Schultz, IEEE Trans. Plasma Sci (26) 6 1998

Plasma Classification

- Equilibrium vs. Non-Equilibrium

LTE = Local Thermodynamic Equilibrium

$$T_e = T_g$$

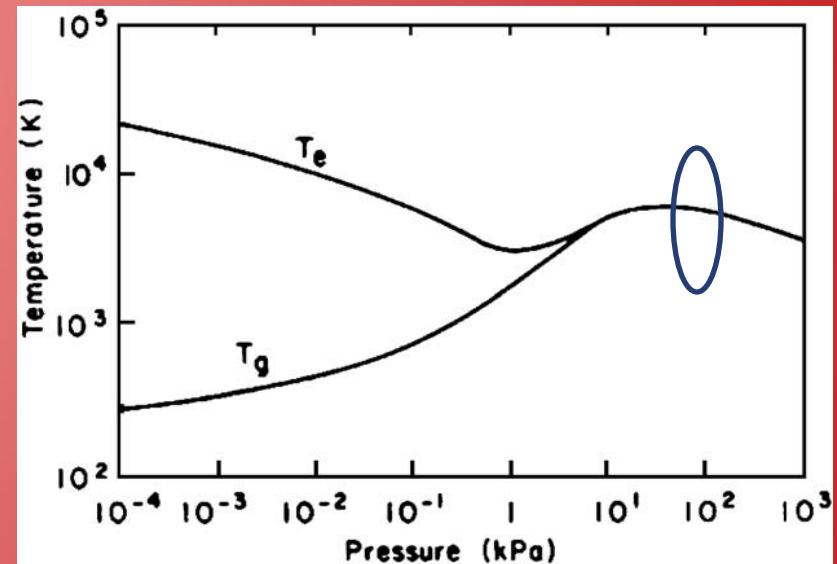
T_e = electron temperature

T_g = gas temperature

- Thermal vs. Cold Plasma

(arc transition)

Ion/neutral temperature
and degree of ionization



Tendero Spectrochim Acta B 2006

1 atm	101.325 kPa (N/m ²)	1.01325 Bar	760mm Hg	760 Torr	14.696 psi
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Frequency Effects

Electrons and ions follow the oscillations of the electric field

Mass
Electron <<< Gas

①

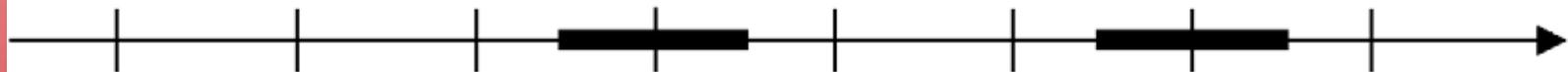
The electrons are the only ones to follow the oscillations of the electric field. The ions are influenced by the average temporal local values of the field.

②

Enhancement of the behaviors observed in zone (2).

③

1 kHz 10 kHz 100 kHz 1 MHz 10 MHz 100 MHz 1 GHz 10 GHz



Low frequency

fpi

Radio frequency

FCC 13.56 MHz

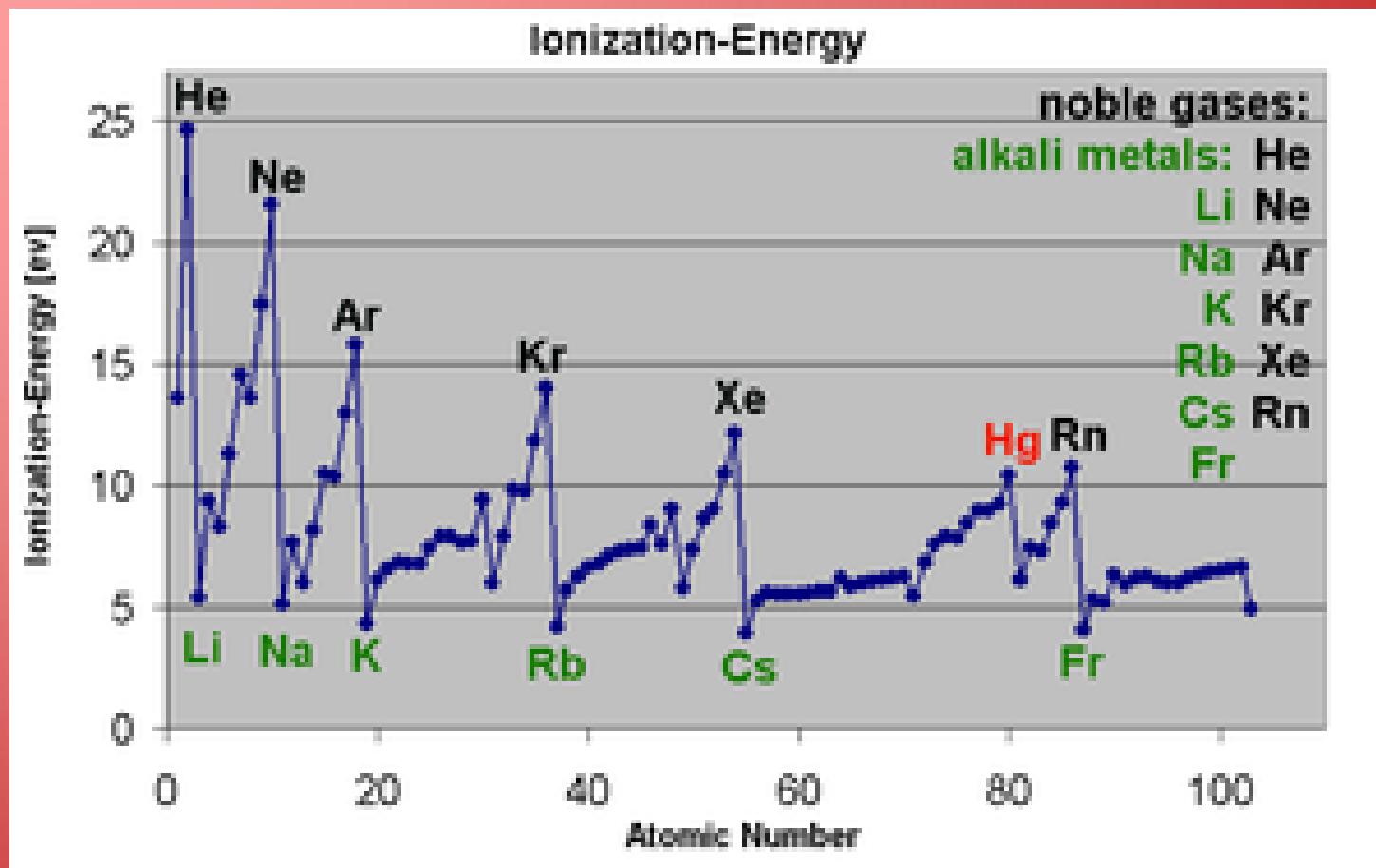
fpe

Microwave

FCC 2.45 GHz

Tendero Spectrochim Acta B 2006

Ionization Energy vs. Atomic Number



Wikipedia.org

Plasma Composition

- Neutrals
He, Ar, O₂, N₂, H₂, CO₂
 - Free electrons
 - Positive and negative ions
 - Stable and meta-stable active species
 - Monatomic and polyatomic species
 - Radicals
- Examples
- O₂ + e- = O₂⁺ + 2e-
 - O₂ + e- = O₂⁻
 - O₂ + e- = O* + O + e-
 - O + O₂ = O₃
 - O₃ + H = OH + O₂
 - N + O₂ = NO + O
 - H + O₂⁻ = OH⁻ + O

Free electron density vs. electron Temperature

Applications

- Cleaning down to the atomic level
Finger oils, silicone oils, hydraulic fluid, sizing, solder flux, carbon soot, machining fluids, mold release agents
- Treatment
Cross linked barrier coatings, dry low friction surfaces
- Deposition
Polymerized hydrocarbon coatings, chemical barriers, scratch resistant coatings, glass-like surfaces, diamond like films

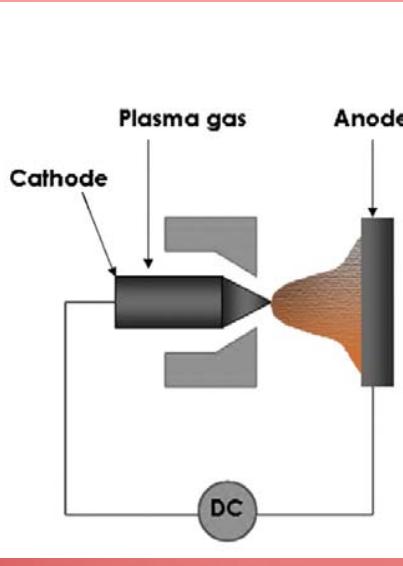
Applications

- Oxidation/reduction
Organic and inorganic functionalities
- Activation.
Hydroxyl, carboxylic, carbonyl, amine, vinyl, thio functionalities
- Adhesion enhancement
Grafting of functional groups, hydrophobic or hydrophilic surface

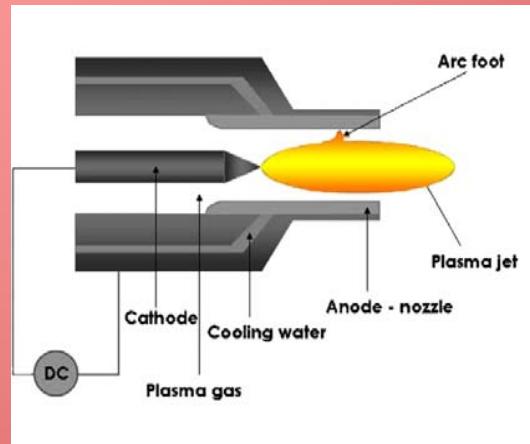
Biomedical Applications

- Sterilization of medical devices and implants
- Air decontamination and biocides
- Antiseptic, fungicide, disinfection
- Bio-functional sites for subsequent attachment of cells, proteins, drugs, bio-conjugated polymers
- Food and food processing disinfection
- Textile chemistry

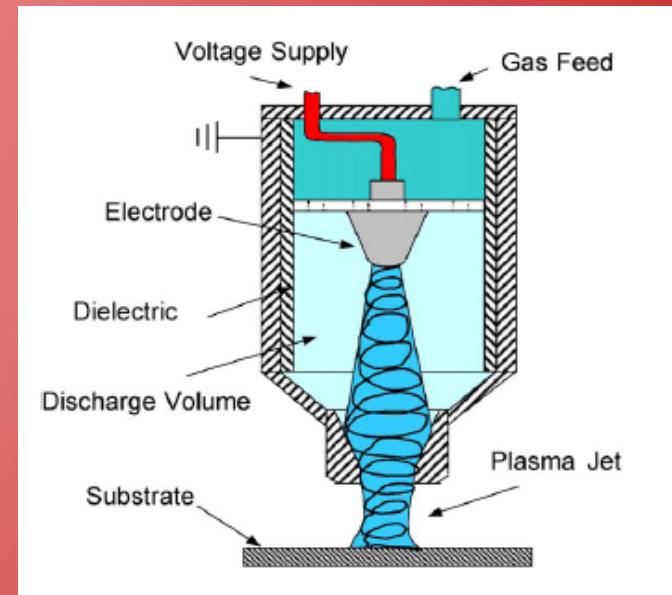
“Torch” Schematics



Transferred Arc



Pilot Arc



Schematic of Hot DC plasma devices

Tendero Spectrochim Acta B 2006

Schematic of a Cold AC plasma device

C. Noeske, Int.J.Adh.Ad. (24) 2004

Atmospheric Plasma “Torches”



Diener
Plasma beam



PVA Tepla
Plasma Pen



AcXys
ULS



Enercon
Dynamite IT



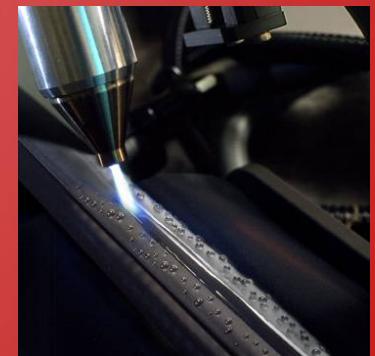
AP Solutions
Plasma Flux



Apjet
Round Jet

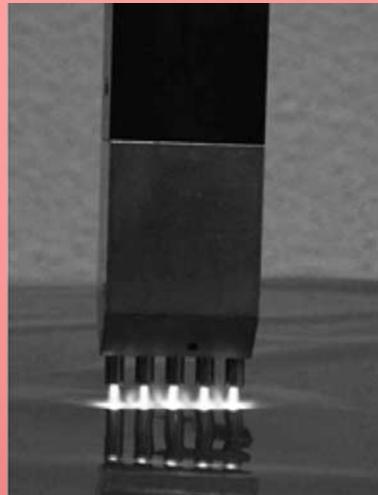


Plasmatreat
FixedJet



Plasma dyne

Multiple Nozzles



PVA Tepla
Plasmapen



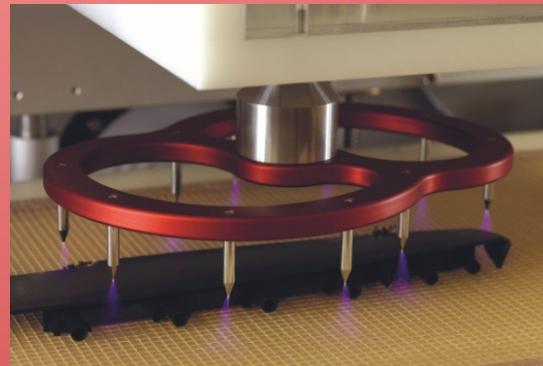
Diener
Dual Beam



AcXys
ULS



Tantec
MonTEC



Tantec
corona

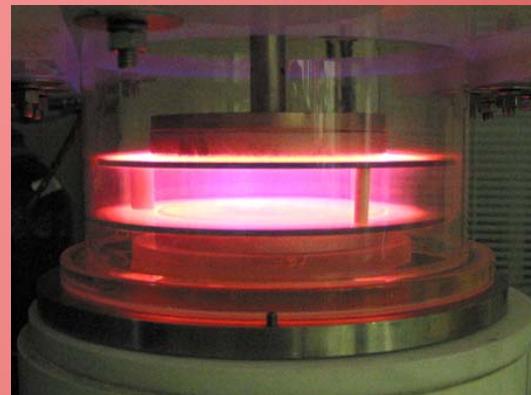


www.bmfd.de

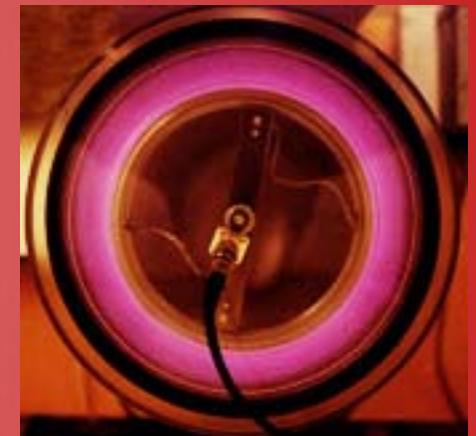
Parallel Plate



AP Solutions



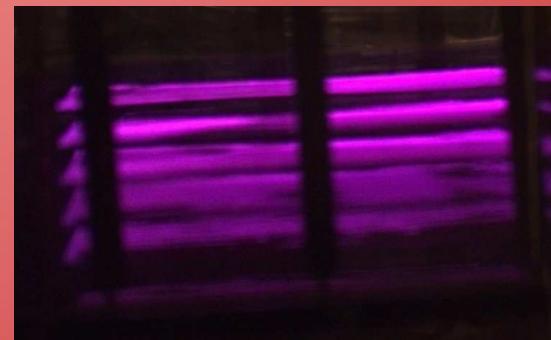
NCSU DBD



Fraunhofer



Enercon Plasma VCP



One Atmosphere Uniform Glow
IEEE Trans. Plasma Sci. 2007

Linear Arrays



Enercon
Plamsa3 VCP



Tantec
SpotTEC



Enercon
DynaAMite



Apjet
Flatjet



Apjet
Texjet

Alternate Geometries



Round Jet

Apjet
Round Jet



Surfx
Atomflo



Surfx
Atomflo

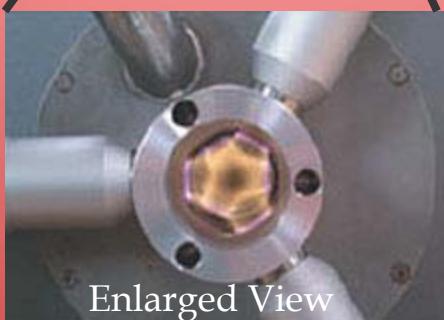


Plasmatreat
RotaryJet

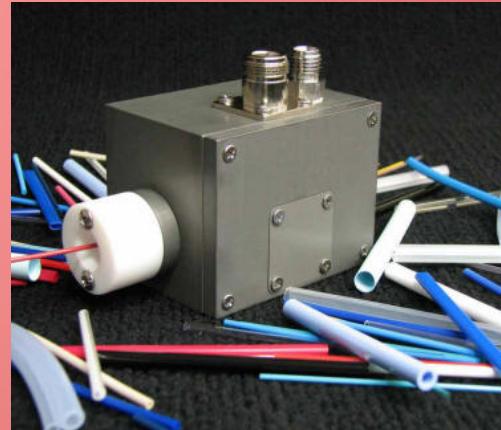


Iplas
Cyrannus

Continuous Profiles



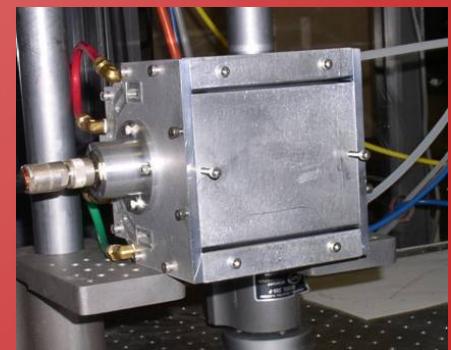
PlasmaTreat
Profile tunnel



Surfx
Atomflo 400T

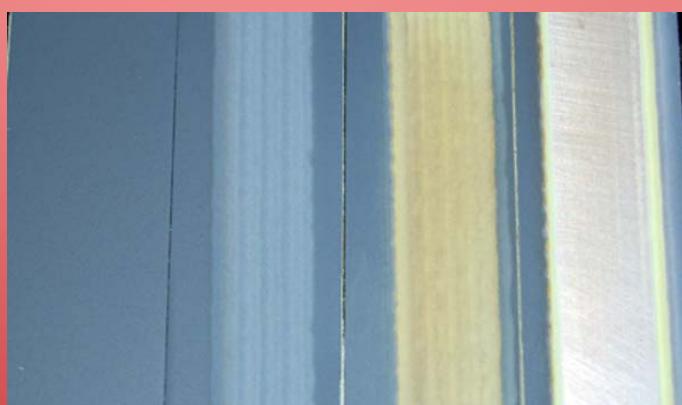


Tantec
CableTEC

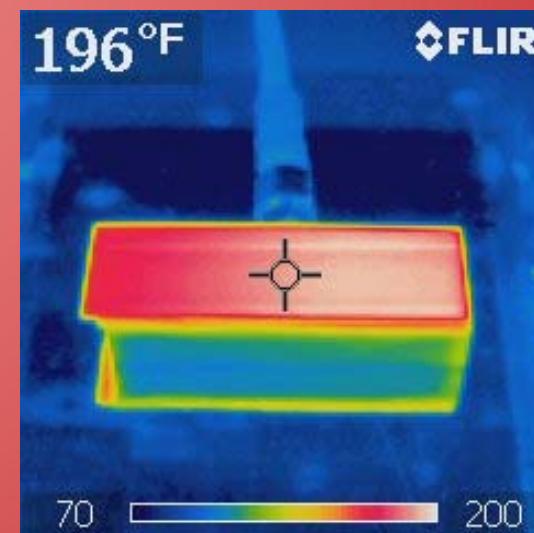


Apjet
Rollerjet

Plasma Paint Removal



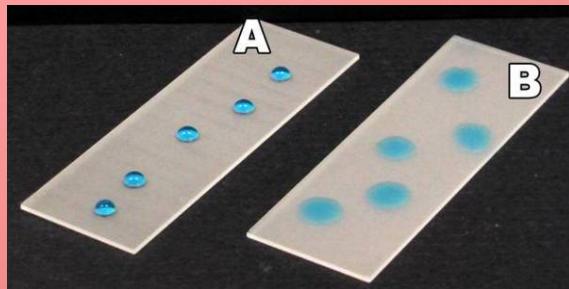
Enlarged View



Layered paint removal from 1"x 3" coupons
MIL 85285/23377 on 2024Al

Infrared image
after treatment

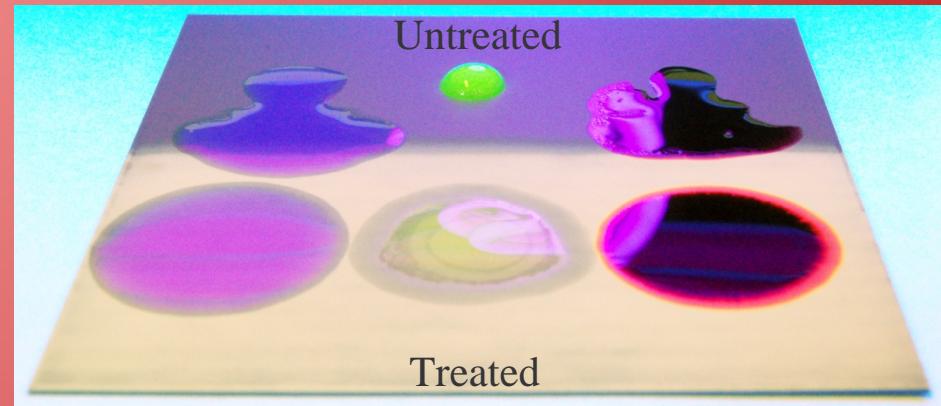
Plasma Treatment Increases Surface Energy



A: Hydrophobic surface before treatment
B: Hydrophilic surface after treatment

Dyne solutions and contact angles can be used to measure surface energy

Hydraulic fluid Water Mineral oil
MIL 83282

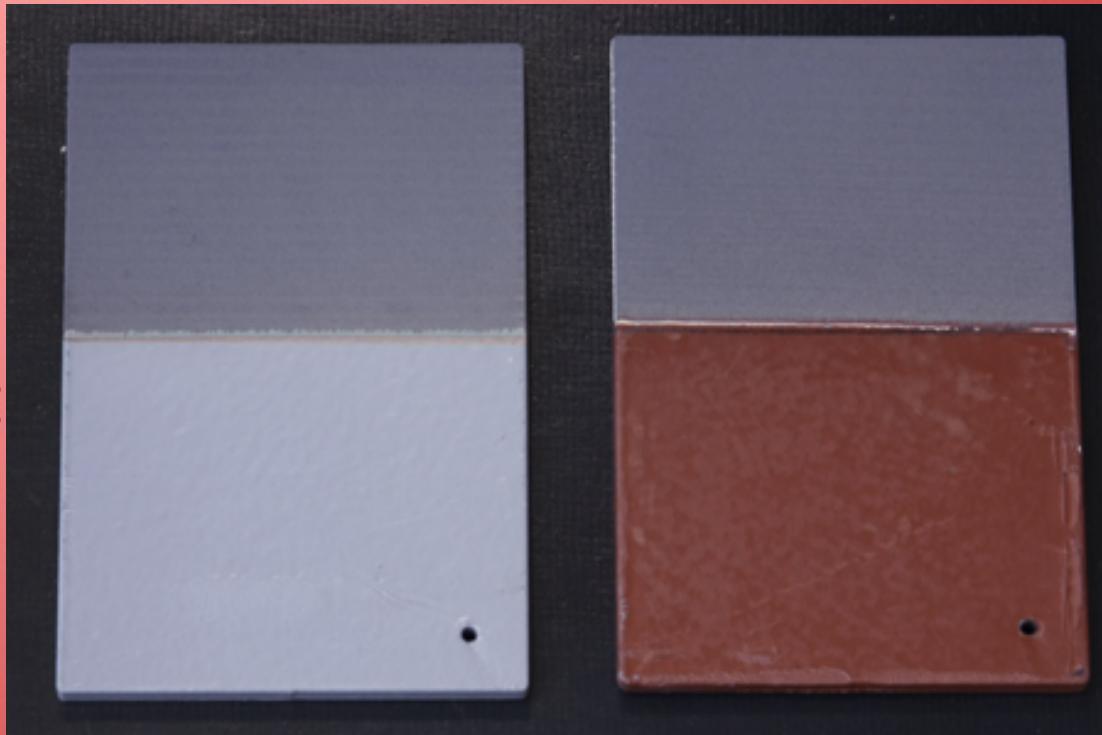


Fluid drops with fluorescent dye on
MIL85285 polyurethane painted
aluminum illuminated with a black light

NAVSEA Paint

After
Plasma

Before
MIL PRF 24635E
Haze Grey
MIL DTL 24443
Epoxy Primer



After
Plasma

Before
MIL 24647
Anti-Fouling
MIL DTL 24443
Epoxy Primer

SSPC SP-10/NACE2 Mild Steel

Si Alkyd Ablative Paint/Steel



Panel subjected to
Seawater Immersion

Base metal after
atmospheric plasma

Plasma Sealant Removal from Fasteners

Before

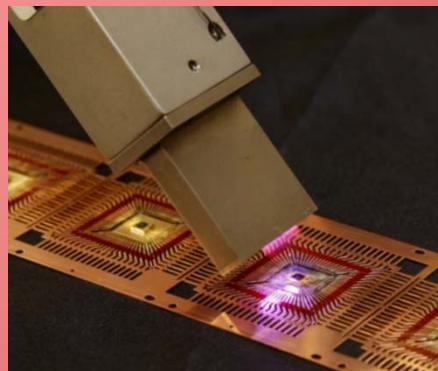
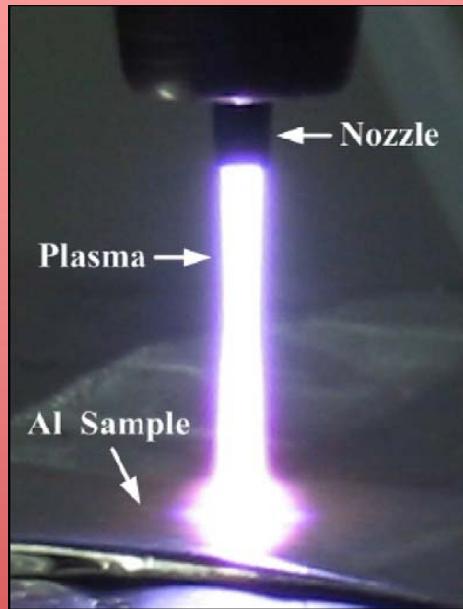


After



MIL-PRF-81733 Polysulfide

Oxidation and Reduction



SurfX
Atomflo



AcXys



D.H. Shin “ μ Wave Plasma”
Surface & Coating and Technology 201 (2007)

Surfx
H2 Plasma

Plasma Electrolytic Polishing and Oxidation

(Micro Arc Oxidation)

- Solid, Liquid, Gas, and Plasma

- Higher voltages than conventional anodizing: $200\text{ V} <$

- Acidic or alkaline aqueous solutions
oxide thickness $< 100\mu\text{m}$

- Crystalline oxides
Hard, tough: Al, Mg, Ti



Keronite.com



Summary

- Atmospheric Plasma is complex
- Numerous applications both for Oxidation and for Reduction
- Rapid Advancement in Applications
- Fundamental Understanding is Lacking

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- *PPG Desoto, AC TECH*
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Thank You



NCSU De-paint Video